

ITW



Group Art Unit: 1753

Examiner: to be assigned

For: METHOD FOR DETECTING THE POSITION OF A SHUTTER DISK IN A PHYSICAL VAPOR DEPOSITION CHAMBER

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on May 6, 2004 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

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Respectfully submitted,

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/702,230	11/06/2003	1753	770	6452D02/CM/L/B/PJS	4	12	2

CONFIRMATION NO. 7955

FILING RECEIPT



OC000000011828337

Patent Counsel
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Date Mailed: 02/05/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

Applied Materials, Inc.; ✓

Domestic Priority data as claimed by applicant ✓ ✓

This application is a DIV of 10/082,480 02/20/2002 PAT 6,669,829

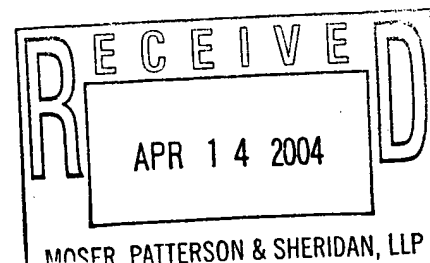
Foreign Applications

If Required, Foreign Filing License Granted: 02/03/2004

Projected Publication Date: 05/13/2004

Non-Publication Request: No

Early Publication Request: No



Title

Method for detecting the position of a shutter disk in a physical vapor deposition chamber

Preliminary Class

204

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Title 37, Code of Federal Regulations, 5.11 & 5.15

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